## **EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	93983	electropolish electroetch etch	EPO; JPO; DERWENT	OR	ON	2007/05/01 11:44
S2	1564510	wafer substrate	EPO; JPO; DERWENT	OR	ON	2007/05/01 11:44
S3	1305404	electrode anode cathode	EPO; JPO; DERWENT	OR	ON	2007/05/01 11:45
S5	2630672	voltage power	EPO; JPO; DERWENT	OR	ON	2007/05/01 11:46
S6	553873	conductive conduct	EPO; JPO; DERWENT	OR	ON	2007/05/01 11:46
<b>S7</b>	256	S1 S2 S3 S5 S6	EPO; JPO; DERWENT	AND	ON	2007/05/01 11:48
S8	2368770	hold\$2 support	EPO; JPO; DERWENT	OR	ON	2007/05/01 11:50
S9	31	S7 S8	EPO; JPO; DERWENT	AND	ON	2007/05/01 12:08
S91	284	205/640.ccls.	US-PGPUB; USPAT	ADJ	ON	2007/05/01 13:51
S92	101	205/686.ccls.	US-PGPUB; USPAT	ADJ	ON	2007/05/01 14:32
S93	224	S91 electrode	US-PGPUB; USPAT	AND	ON	2007/05/01 14:35
S97	186	S93 (polish\$3 or etch\$3)	US-PGPUB; USPAT	AND	ON	2007/05/01 14:52